

Docket No.: 2336-181



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Inventor(s): PARK, Young Ho et al. : Confirmation No.1487  
U.S. Patent Application No. 10/601,597 : Group Art Unit: 2822  
Filed: June 24, 2003 : Examiner: MONICA LEWIS  
For: VERTICAL GaN LIGHT EMITTING DIODE AND METHOD FOR  
MANUFACTURING THE SAME

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of the first Office Action on the merits, but before the mailing date of the Final Rejection or Notice of Allowance.

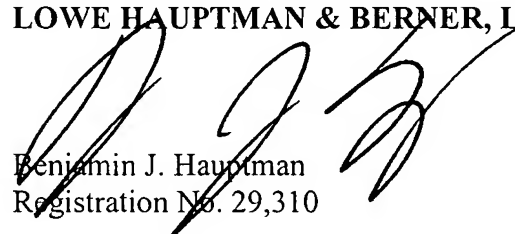
**CERTIFICATION PARAGRAPH**

The undersigned hereby certifies that no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart

foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in Sec. 1.56(c) more than three months prior to the filing of the information disclosure statement (37 CFR 1.97(e)(2)).

Respectfully submitted,

**LOWE HAUPTMAN & BERNER, LLP**



Benjamin J. Hauptman  
Registration No. 29,310

1700 Diagonal Road, Suite 300  
Alexandria, Virginia 22314  
(703) 684-1111 BJH/jk  
Facsimile: (703) 518-5499  
**Date: April 5, 2005**



**INFORMATION DISCLOSURE  
CITATION IN AN  
APPLICATION**

(PTO-1449)

ATTY. DOCKET NO.  
2336-181

U.S. PATENT  
APPLICATION NO.  
10/601,597

APPLICANT  
**PARK, Young Ho et al.**

FILING DATE  
June 24, 2003

GROUP  
2822

**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	6,169,296	1/2001	Kamiyama et al			

**FOREIGN PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	1999-37429 (U.S. 6,169,296)	5/1999	Korea				
	2002-299683	10/2002	Japan				

**OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)**


EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.